

Serial No. 10/029,253
Reply to Office Action of February 24, 2005 and
Advisory Action dated June 17, 2005

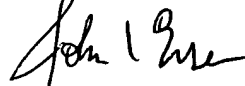
Docket No. K-0381

REMARKS

In view of the foregoing remarks and the enclosed English Translation of Korean Patent Application No. 2000-0085014, it is respectfully submitted that the application is in condition for allowance and favorable consideration and prompt allowance are earnestly solicited. If the Examiner believes that any additional changes would place the application in better condition for allowance, the Examiner is invited to contact the undersigned attorney at the telephone number listed below.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this, concurrent and future replies, including extension of time fees, to Deposit Account 16-0607 and please credit any excess fees to such deposit account.

Respectfully submitted,
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Date: June 27, 2005

Enclosure: English Translation of Priority Korean Patent Application 2000-0085014

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